

IEW 2876 \$

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. OKI.237	
In Re Application Of: Ryoichi Matsumoto DEC 21 2005					
Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
09/864,189	May 25, 2001	T. Le	20987	2876	2192
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE					
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
37 CFR 1.97(b)					
1. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.					
37 CFR 1.97(c)					
2. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:					
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e);					
OR					
<input checked="" type="checkbox"/> the fee set forth in 37 CFR 1.17(p).					

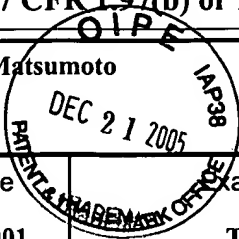
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(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
OKI.237

In Re Application of: **Ryoichi Matsumoto**



Application No. 09/864,189	Filing Date May 25, 2001	Examiner T. Le	Customer No. 20987	Group Art Unit 2876	Confirmation No. 2192
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Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE**

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Substitute for form 1449/PTO

(Use as many sheets as necessary)

Sheet	1	of	1
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Application Number	09/864,189
Filing Date	May 25, 2001
First Named Inventor	Ryoichi Matsumoto
Art Unit	2876
Examiner Name	T. Le
Attorney Docket Number	OKI.237

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**Examiner
Signature**

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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